

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masaharu KAWAKUBO et al.

Group Art Unit: 4175

Application No.:

10/581,060

Examiner:

C. RIDDLE

Filed: May 30, 2006

Docket No.: 127873

For:

EXPOSURE METHOD AND DEVICE MANUFACTURING METHOD, EXPOSURE

APPARATUS, AND PROGRAM

## **AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the December 8, 2008 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.